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P/1596-73

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	New York, New York
Atsushi OSAWA	Date: May 24, 2004
Serial No.: 10/785,685	Group Art Unit: ---
Filed: February 23, 2004	Examiner: ---

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
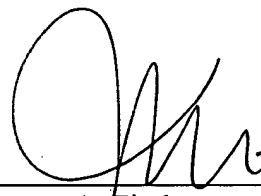Alexandria, VA 22313-1450

<u>SUBMISSION</u>

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on May 24, 2004

James A. Finder
_____
Name of applicant, assignee or Registered Representative

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Signature
May 24, 2004
Date of Signature

Respectfully submitted,

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Enclosures

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APPLICANT'S ART CITATION	Application 10/785,685	OFGS File No. P/1596-73
(Use several sheets if necessary)	Applicant Atsushi OSAWA	
	Filing Date February 23, 2004	Group Art Unit ---

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-3,869,313	03-1975	Jones et al.	134	73	
	US-					
	US-					
	US-					
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	US-					
	US-					
	US-					
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FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.